

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **OZAKI, Takashi, et al.**

Group Art Unit: **1792**

Serial No.: **10/528,137**

Examiner: **MACARTHUR, Sylvia**

Filed: **December 12, 2005**

P.T.O. Confirmation No.: **2307**

FOR: **SUBSTRATE PROCESSING APPARATUS AND METHOD FOR
MANUFACTURING A SEMICONDUCTOR DEVICE**

REQUEST FOR STATUS

Assistant Commissioner for Patents
Washington, D.C. 20231

October 15, 2010

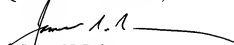
Sir:

The undersigned agent requests the status of the above-identified application.

A Request for Continued Examination was filed on March 9, 2010 in the U.S. Patent and
Trademark Office and to date no Office Action has been received.

Respectfully submitted,

KRATZ, QUINTOS & HANSON, LLP



James N. Baker
Agent for Applicant
Reg. No. 40,899

JNB/ak

Atty. Docket No. **050161**
Suite 400
1420 K Street, N.W.
Washington, D.C. 20005
(202) 659-2930



23850

PATENT & TRADEMARK OFFICE